



85578RLO  
Customer No. 01333

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Jeremy M. Grace, et al

THERMAL PHYSICAL VAPOR  
DEPOSITION SOURCE WITH  
MINIMIZED INTERNAL  
CONDENSATION EFFECTS

Serial No. US 10/786,859

Filed 25 February 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA. 22313-1450

Sir:

Group Art Unit: 2818  
Confirmation No. 3654  
Examiner: Thao P. Le

I hereby certify that this correspondence is being  
deposited today with the United States Postal  
Service as first class mail in an envelope addressed  
to Commissioner For Patents, P.O. Box 1450,  
Alexandria, VA 22313-1450.

Joyce Delrie

Date

12.8.04

**Amendment**

In response to the Office Action mailed October 4, 2004, please  
reconsider the rejection of the above-identified application, without prejudice, in  
view of the following remarks.

**Amendments to the Drawings** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.